

2818
#5
7-22
COPY OF PAPERS
ORIGINALLY FILED

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)

Shunpei YAMAZAKI et al.)

Art Unit: 2818

Serial No. 10/084,935

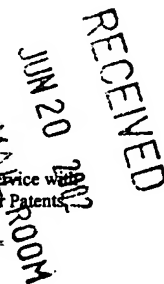
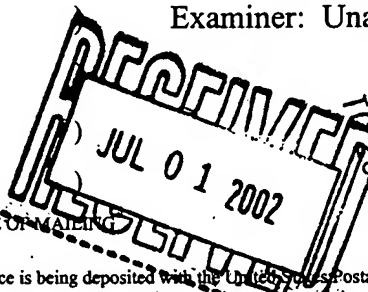
Examiner: Unassigned

Filed: 03/01/2002

For: INSULATING FILM AND METHOD OF
PRODUCING SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 6/4/2002.

**INFORMATION DISCLOSURE STATEMENT AND****SUPPLEMENT TO PRIOR INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents and Trademarks

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Initially, Applicants note that JP 01-238024, JP 03-036767 and JP 05-267480 were previously submitted in the subject application with English language abstracts provided on the Form PTO-1449. These references were cited in the parent applications. Applicants note that full translations were provided for these references in Serial No. 09/466,828. As a result, the Examiner's attention is directed to the full English translations of these references submitted herein.

JP 04-295826 was cited in a Japanese Office Action for allegedly teaching the use of quartz or a single crystal silicon as a target for forming a gate insulting film. US 5,585,949 is in the family of JP 04-295826.

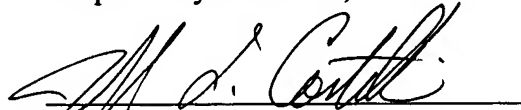
In accordance with 37 C.F.R. § 1.97(e), it is certified (with the exception of US 5,585,949 and the three full translations provided herein as a correction to prior IDS) that either (1) each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a

- 2 -

counterpart foreign application not more than three months prior to the filing of this information disclosure statement, or (2) no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign patent application and no item of information contained in the information disclosure statement was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this information disclosure statement.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,



Jeffrey L. Costellia
Reg. No. 35,483

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110